

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/633,230	<b>Applicant(s)/Patent under Reexamination</b> MIWA, TADASHI
	<b>Examiner</b> Andy Huynh	<b>Art Unit</b> 2818

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
EAST 257/208,239,261,298,315-326 (text search-see search history printout)	12/6/2004	AH
EAST Text search-see search history printout	5/19/2005	AH
Interference Search History Printout	9/7/2005	AH